

Manufacturing Development of a New Electroplated Magnetic Alloy Enabling Commercialization of PwrSoC Products

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- Technology landscape and roadmap
- Need for <u>Wafer Level Magnetics</u>
- Path to PowerSoC
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POWER MANAGEMENT MARKET FORCES





ENPIRION

Industry wide demands are challenging power designs to deliver Higher Efficiency, Smaller Size and Lower Noise @ LOWEST Cost



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OVERVIEW

- Market forces are driving Power Electronics towards Power System in Package (PSiP) and even further towards Power System on Chip (PwrSoC)
- Enpirion's customers driving Power-System-on-Chip integration to enable smallest footprint, highest performance, higher reliability without compromising cost per watt
 - Enpirion shipped PSiP in 2005
- Enpirion is commercializing first PwrSoC based on Wafer Level Magnetics – FCA technology in 2012



WAFER LEVEL MAGNETICS INTEGRATION

(Enabled by Operating at High Frequency)

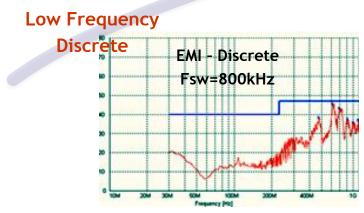
Discrete

High Part Count Large Foot Print Layout Issues Noisy signals on PC Board





Medium Frequency Discrete

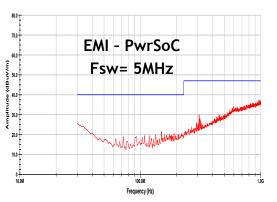


Power SoC

3 external capacitors Very small foot print Smaller value capacitors Very quiet signals on PC board



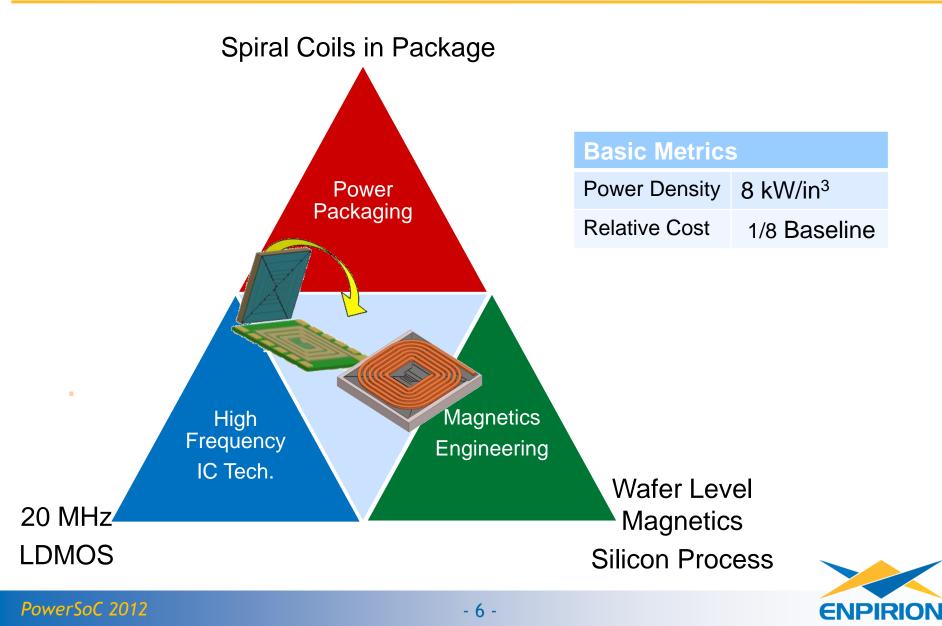
High Frequency Power SoC



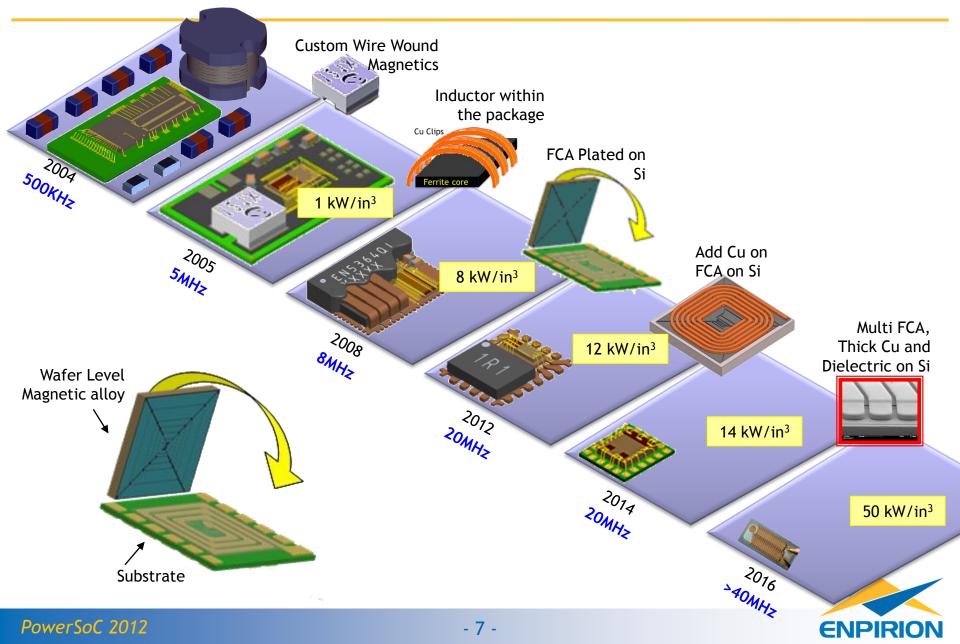


3-PRONG TECHNOLOGY DEVELOPMENT

(2012: Gen 4; PwrSoC Introduction)

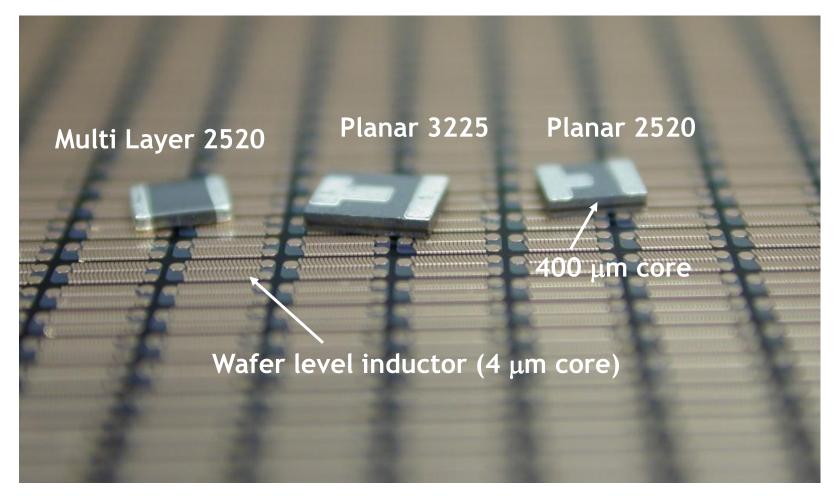


DC-DC POWER CONVERTER INTEGRATION



WAFER LEVEL MAGNETICS

(Going from 3D to 2D)



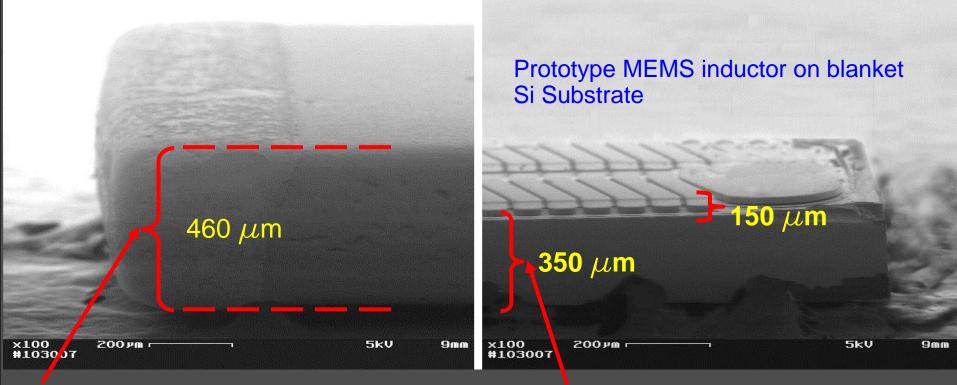
FCA film magnetic core is ~100 times thinner than discrete inductor core



OUR VISION: COMPLETE DC-DC SOLUTION

(In less volume than a tiny discrete inductor)

- In scale size comparison -



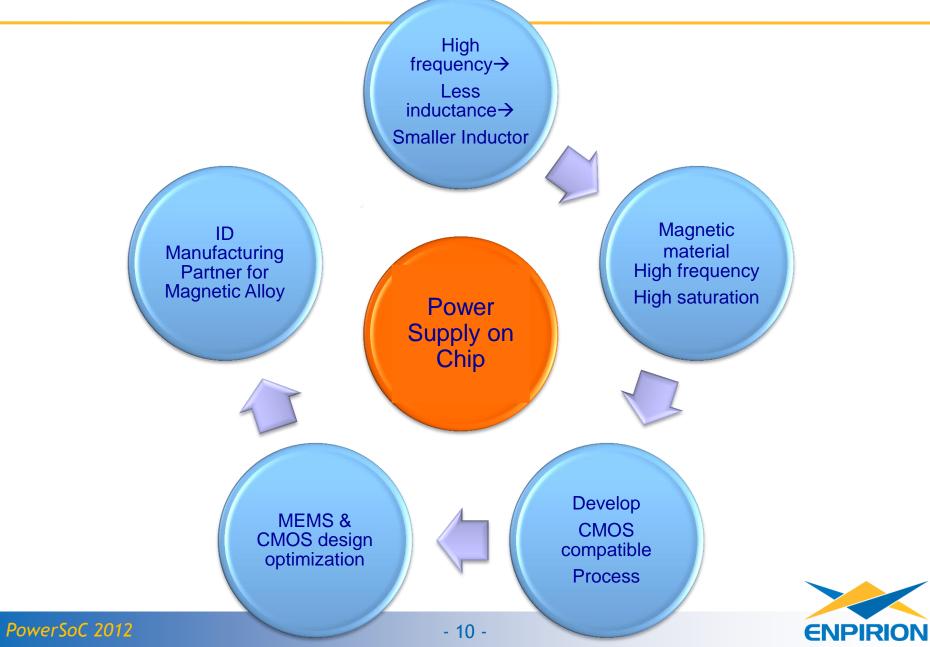
Just a Discrete Inductor

Monolithic Solution: Active Inductor(~150 μ m)

CMOS buck-boost circuitry

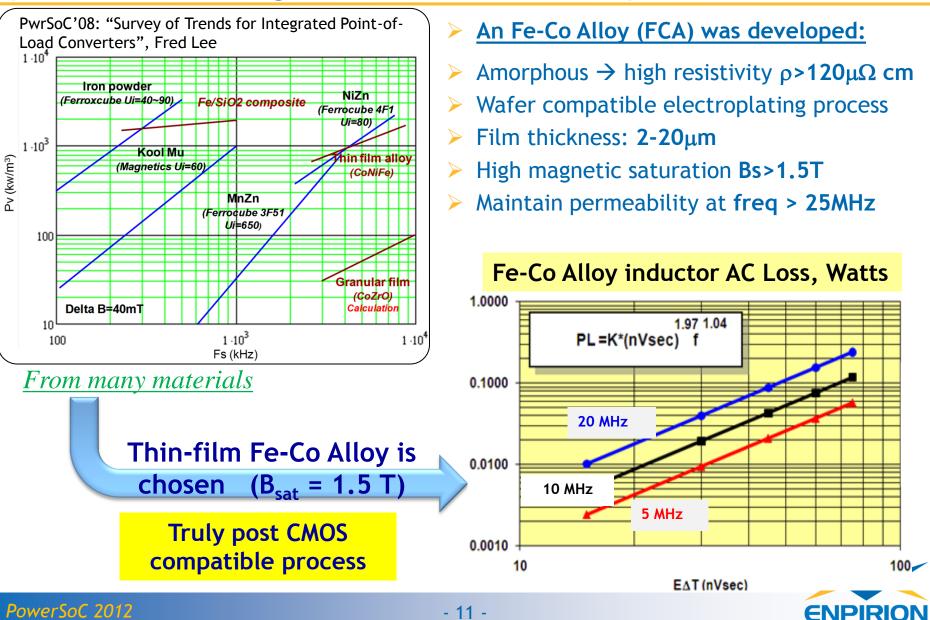


BUILDING INTEGRATED POWER CONVERTER



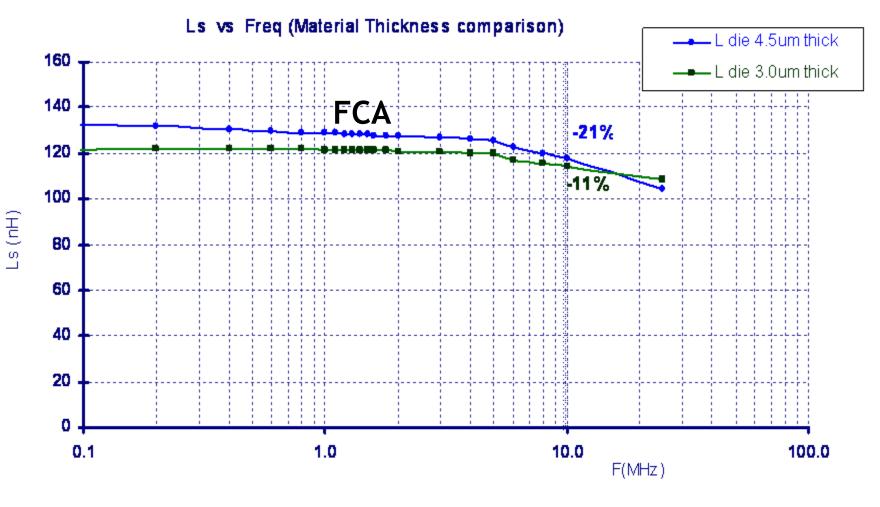
CHOOSING THE ALLOY;

(Power SoC Magnetic Materials Used)



FCA MAGNETIC MATERIAL

(High Frequency Performance)





PowerSoC 2012

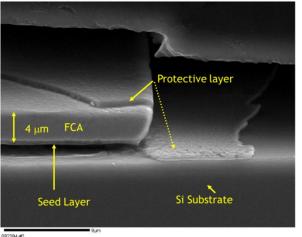
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FCA MANUFACTURING

(Process Challenges)

- Stress
 - Impact on front end assembly processes back grind, dicing
 - Impact on electrical characteristics
- Magnetic Alloy Consistency
 - Composition
 - Thickness
- Optical Inspection Standards
 - Impact on electrical performance
 - Impact on reliability
- Electrical Performance Validation
 - Magnetic Coupling (magnetic material)
 - Galvanic Connection (inductor on wafer)

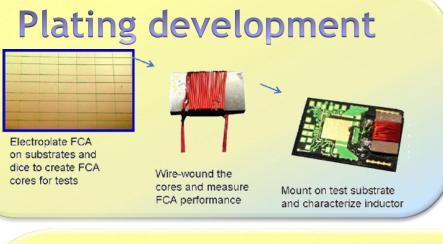


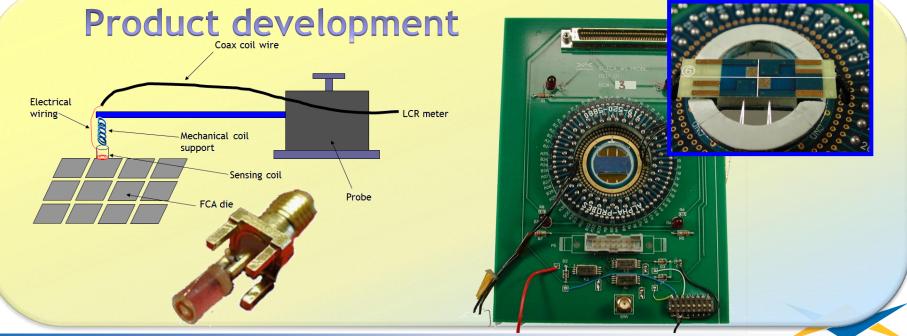




PROCESS CONTROL

(Development and Pilot Phase Tests)





PowerSoC 2012

ENPIRION

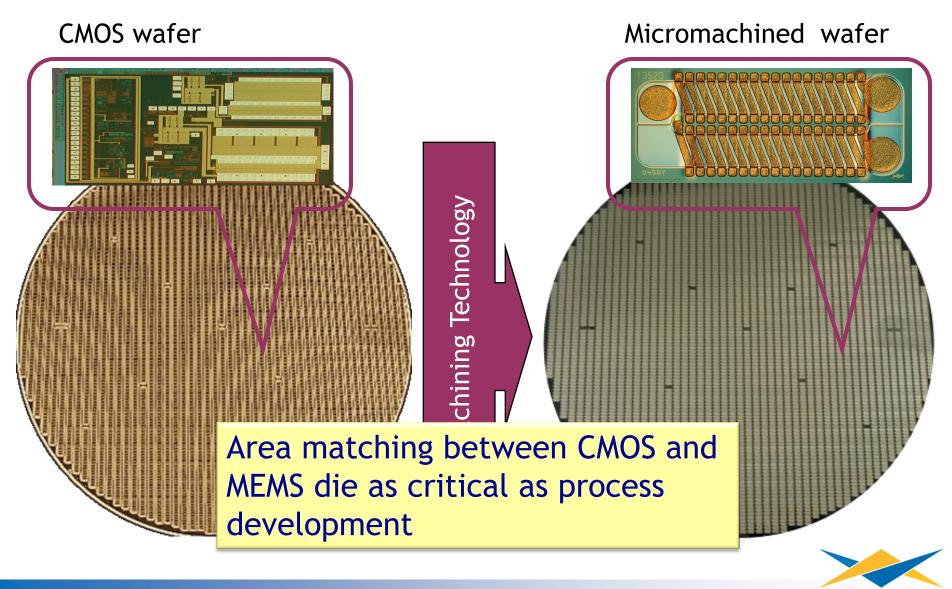
PROCESS CONTROL IN PRODUCTION

(Tests and Measurements)

- Establish correlation of plating process and procedures with deposited alloy characterization
- Control the plating parameters
 - Current efficiency
 - Current density
 - pH
- Monitor the bath chemistry
- Run material composition validation tests after certain number of plated lots



FCA IS POST-CMOS COMPATIBLE

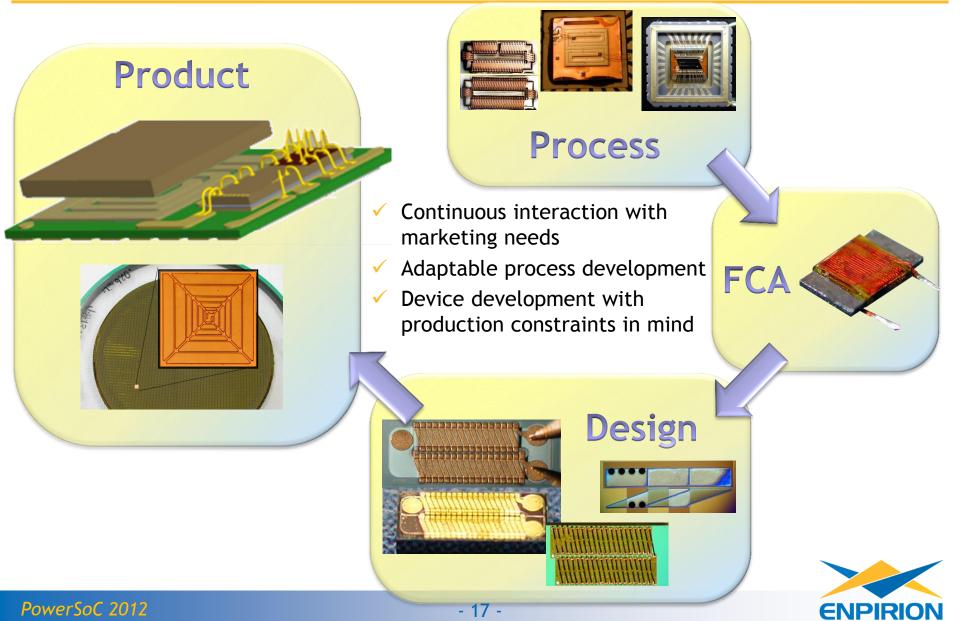


PowerSoC 2012

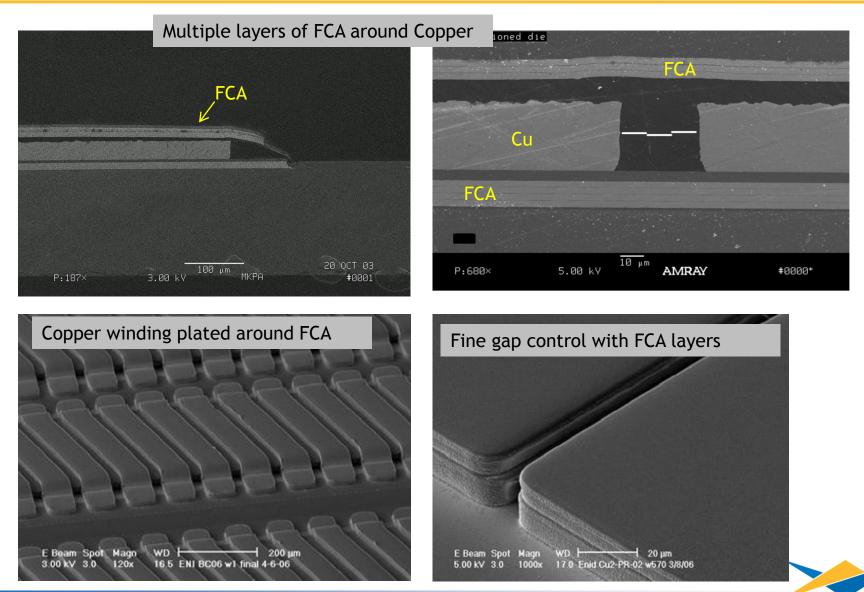
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DESIGN ITERATIONS and DEVELOPMENT

(Quest For Optimum Micro-Inductor Application)



FCA APPLICATIONS (Multi – layers deposition is possible)

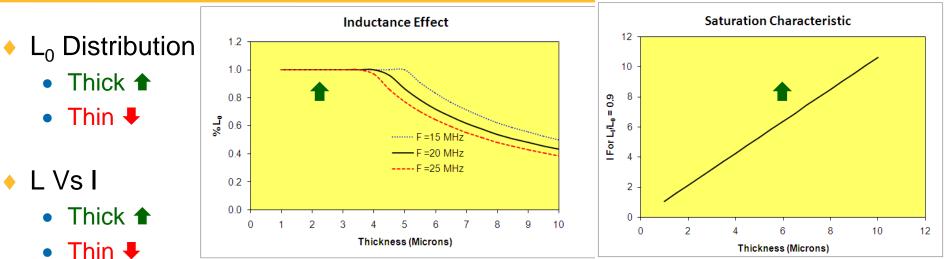


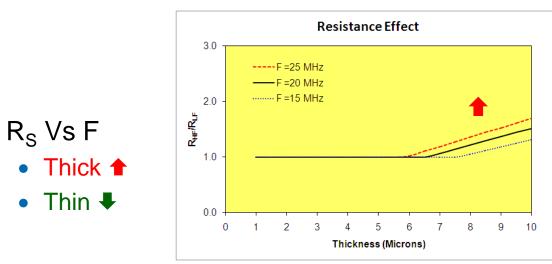
PowerSoC 2012

ENPIRION

FCA DESIGN CONSIDERATIONS & TRADE OFFS

(Effects of Magnetic Alloy Thickness Variation)



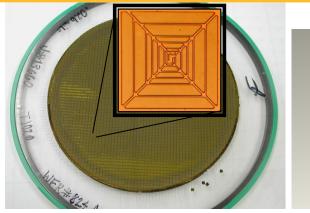


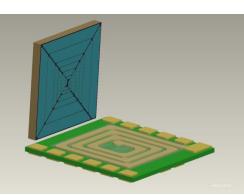
Must balance the benefits of thicker film with the Power Loss penalty

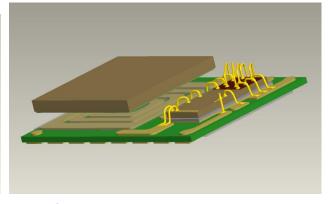


Introduction of Wafer Level Magnetic

(Simple but effective inductor design at mature process cost)



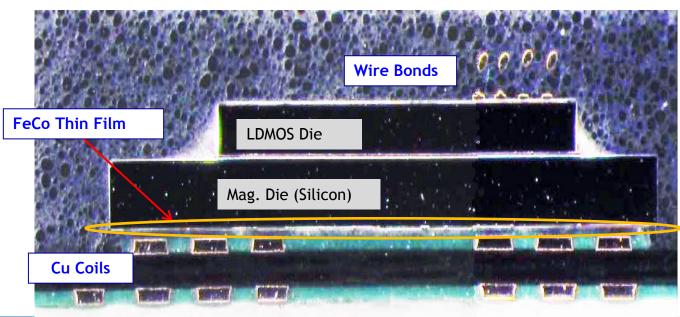


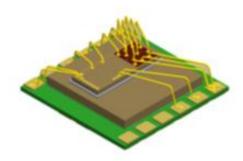


Step 1. Electroplate FCA on wafer

Step 2. Flip FCA over a Cu spiral coil

Step 3. Package PowerSoC







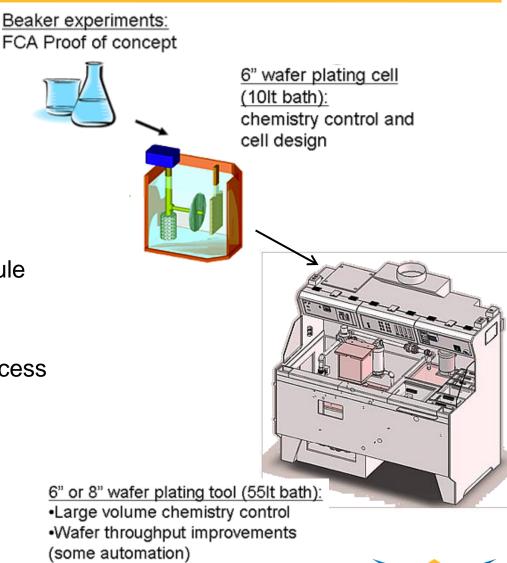
TRANSFER MAGNETIC PLATING IN WAFER FABS

- Traditional wafer fabs are not compatible with magnetic plating process
- Back end wafer processing fabs are more suitable for magnetic plating
 - Wafer bumping fabs
 - Cu redistribution layer fabs
- Packaging facilities with post-CMOS processing are found to be ideal
- Lower the COST & TIME barrier of process development
 - Simplify manufacturing process (simple but effective design)
 - Process transfer rather process development
 - Prepare turn key process module ready for transfer with minimum or no capital investment
- Address materials and consumables requirements, restrictions and availability in the production facility
 - Import / export restrictions
 - Shipping costs and taxes
 - Lead times and quality standards



ENPIRION'S PATH TO PRODUCTION

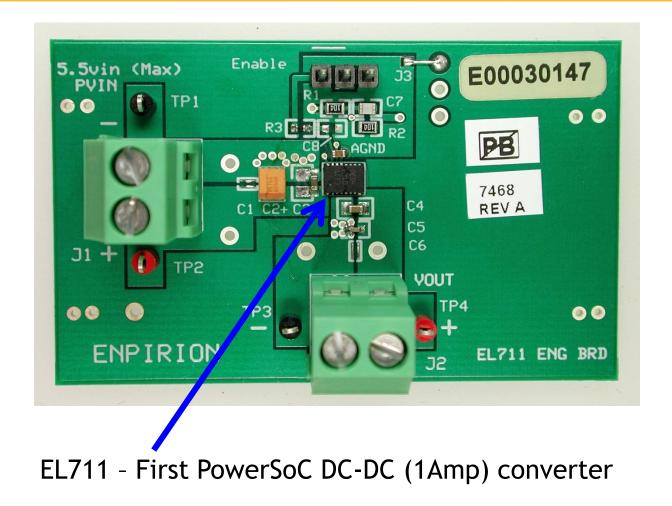
- Proof of concept
 - Small scale prototype (Bench top)
- Design and build production equipme
- Setup an FCA pilot facility
 - Process validation
 - Generate engineering samples
- Enable turn-key plating process module
 - Includes: Chemistry, process and equipment
- ID partner foundry for early stage process support and volume production'
- Transfer process / equipment in production line
- Qualify production process



•Mixing and rinsing procedures



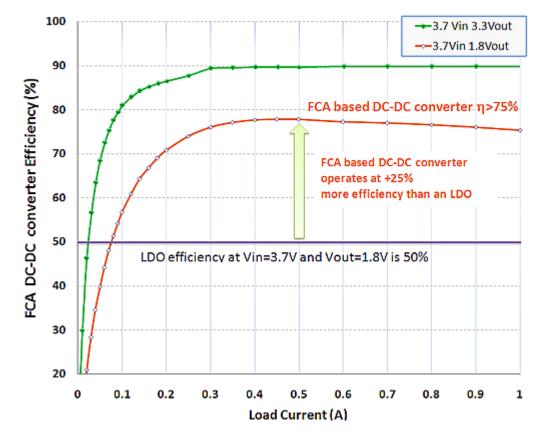
IN PRODUCTION FIRST PowerSoC

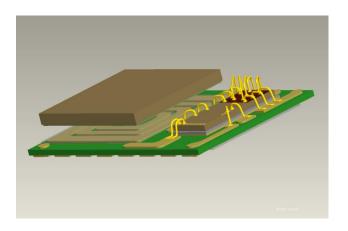




FCA in Enpirion's first PwrSoC product

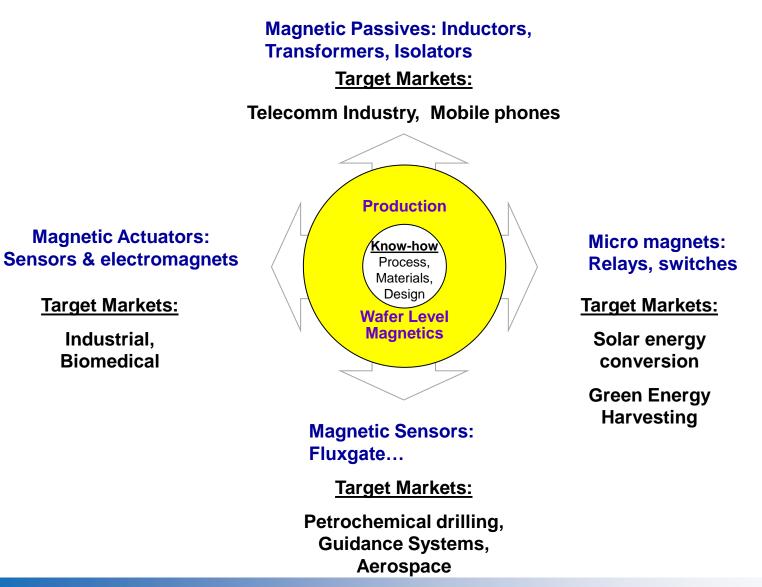
- Enpirion implement FCA in its first PwrSoC product
- FCA offered +25% improvement in efficiency over existing solutions







WAFER LEVEL MAGNETICS (Other possible FCA Applications)





CONCLUSIONS

- Power management market drives the need for solutions:
 - Smaller
 - Efficient
 - Cost effective
- Wafer Level Magnetics integration is enabled by operating at high frequencies
- FCA was created to meet the high magnetic performance requirements for Wafer Level Magnetic based power devices
- Develop competitive technology in a cost effective way
 - Continuous interaction with marketing needs
 - Focus on target product support
- Strategy: Setup a pilot facility to create a transferable FCA plating module
- Identify the right manufacturing partner
- FCA wafer level magnetic core enables industry's first PwrSoC



THANK YOU FOR YOUR ATTENTION

